



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Toru TAKAYAMA et al.

) Group Art Unit: 2818  
) Examiner: T. Le

Serial No. 10/664,866

) CERTIFICATE OF MAILING

Filed: September 22, 2003

) I hereby certify that this correspondence is  
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) Commissioner for Patents, P.O. Box 1450,  
) Alexandria, VA 22313-1450, on 12-12-05.

For: METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE AND  
HEAT TREATMENT METHOD

) Adeline M. Stamps

**INFORMATION DISCLOSURE STATEMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, which waives the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

This Information Disclosure Statement is being submitted with an RCE. Therefore, no fee is required.

Respectfully submitted,

  
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